Electronic Acknowledgement Receipt FES ID: 1136311 Application Number: 10792323 Confirmation Number: 4370 Apparatus and method for vaporizing solid precursor for CVD or atomic Title of Invention: layer deposition First Named Inventor: Lawrence C. Lei Customer Number: 44257 Filer: Keith M. Tackett/Tammi Thomas Filer Authorized By: Keith M. Tackett Attorney Docket Number: AMAT/5191C1/ISM/CORE/MCVD Receipt Date: 01-AUG-2006 Filing Date: 03-MAR-2004 Time Stamp: 16:15:39 Application Type: Utility International Application Number: Payment information:

File Listing:

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ĺ	Document Number	Document Description	File Name	File Size(Bytes)	Multi Part	Pages
	1		005191C1Y1_ROA_EF.pdf	351079	yes	9

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	Multipart Description			
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	Amendment - After Non-Final Rejection	1	5	
	Applicant Arguments/Remarks Made in an Amendment	6	9	
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If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/IDO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filling Receipt, in due course.